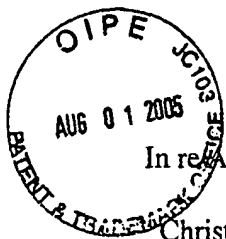


TT4314 Ifw
AF



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Christopher L. Wooten, et al.

Group Art Unit: 2623

Appl. No.: 09/976,739

Examiner: Wesley J. Tucker

Filed: October 11, 2001

Title: METHOD FOR EVALUATING ANOMALIES IN A SEMICONDUCTOR
MANUFACTURING PROCESS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION TRANSMITTAL

1. Transmitted herewith is a Response for this application.
2. The fee for claims has been calculated as follows:

<u>CLAIMS AS AMENDED</u>									
	<u>Claims After</u>		<u>No. Prev.</u>		<u>Present</u>		<u>Rate - Small</u>		<u>Add'l</u>
	<u>Amendment</u>		<u>Paid For</u>		<u>Extra</u>				<u>Fee</u>
Total	20	-	20	=	0	x	\$50.00	=	0.00
Indep.	3	-	3	=	0	x	\$200.00	=	0.00
Filing Fee Calculation:									<u>\$0.00</u>

3. The total fees to be paid are as follows and are enclosed payable to the

Commissioner of Patents and Trademarks:

Fee for claims adjustment:	0.00
Extension fee:	<u>0.00</u>
Total Fees Due:	<u>\$0.00</u>